



EV318285108

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. 09/905,320
Confirmation No. 6172
Filing Date July 13, 2001
Inventor Cem Basceri et al.
Assignee Micron Technology, Inc.
Group Art Unit 1762
Examiner Eric B. Fuller
Attorney's Docket No. MI22-1657
Customer No. 021567
Title: Chemical Vapor Deposition Methods of Forming Barium Strontium
Titanate Comprising Dielectric Layers, Including Such Layers Having a
Varied Concentration of Barium and Strontium Within the Layer

RESPONSE TO JUNE 30, 2003 OFFICE ACTION

To: Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

VIA U.S. EXPRESS MAIL

From: Mark Matkin (Tel. 509-624-4276; Fax 509-838-3424)
Wells St. John P.S.
601 West First Avenue, Suite 1300
Spokane, WA 99201-3828

Responsive to the Office Action dated June 30, 2003, Applicant
remarks as follows:

AMENDMENTS

Amendments to the Claims

None.